



Docket No.: 43890-449

#15
6-13-03
Mullen
PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Hidenori KAMEI, et al.

Serial No.: 09/680,943

Group Art Unit: 2823

Filed: October 10, 2000

Examiner: George Fourson

For: **P-TYPE NITRIDE SEMICONDUCTOR AND METHOD OF
MANUFACTURING THE SAME**

REQUEST FOR RECONSIDERATION

Mail Stop Non-Fee Response
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated April 10, 2003, having a three-month shortened statutory period for response set to expire on July 10, 2003, reconsideration of the above-identified application is respectfully requested in view of the following remarks.

INFORMATION DISCLOSURE STATEMENT

As part of the outstanding Office Action, the Examiner provided Applicants an initialed copy of the Information Disclosure Statement filed on November 27, 2002. However, the Examiner did not initial EP 0805500A1 and did not provide any basis for not doing so (courtesy copy of initialed IDS received from Examiner enclosed herein). It is respectfully requested that the Examiner please provide Applicants another initialed

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